



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. .... 09/834,660  
Filing Date ..... April 21, 2001  
Inventor ..... Luan C. Tran  
Assignee ..... Micron Technology, Inc.  
Group Art Unit ..... 2813  
Customer No. ..... 021567  
Confirmation No. ..... 6625  
Examiner ..... Laura Schillinger  
Attorney's Docket No. ..... MI22-1637  
Customer No. ..... 021567  
Title: Semiconductor Processing Methods

**SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT**

References –See Attached Form PTO-1449

The Examiner's attention is directed to the references which are listed on the attached Form PTO-1449, copies of which are attached. No admission is made regarding whether all the submitted references are prior art.

Citation of the referenced art is respectfully requested.

Respectfully submitted,

Dated: 5/23/05

By:   
James D. Shaurette  
Reg. No. 39,833

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Form PTO-1449 <i>O I P E J C T A Y</i> MAY 24 2005 PATENT & TRADEMARK OFFICE		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. MI22-1637		SERIAL NO. 09/834,660	
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)				APPLICANT Luan C. Tran			
				FILING DATE April 21, 2001		GROUP 2813	
U.S. PATENT DOCUMENTS							
*Examine Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
	AA	6,834,019	12/2004	Tran et al.			
	AB	6,734,487	5/2004	Tran et al.			
	AC	6,228,713	5/2001	Pradeep et al.			
	AD	6,501,114	12/2002	Cho et al.			
	AE	6,620,704	9/2003	Miura et al.			
	AF	6,436,751	8/2002	Liou et al.	<i>EY550714975</i>		
	AG	6,770,927	8/2004	Cho et al.			
	AH	2004/0188777 A1	10/2004	Hwang			
	AI	2004/0214355 A1	10/2004	Miura et al.			
	AJ						
	AK						
FOREIGN PATENT DOCUMENTS							
		Document Number	Date	Country	Class	Subclass	Translation
	AL						Yes      No
	AM						
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)							
	AN		Van Zant, Peter, "Microchip Fabrication - Third Edition," ©1997, page 332.				
EXAMINER				DATE CONSIDERED			
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							